

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-2482		PRIORITY SERIAL NO. 10/293,164	
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT: J. Brett Rolfson			
				PRIORITY FILING DATE November 12, 2002		PRIORITY GROUP ART NO. 1758 1763	
U.S. PATENT DOCUMENTS							
Examiner's Initials	Class	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
gag	AA	4,377,437 /	03/22/83	Taylor et al.			
	AB	5,853,925 /	12/29/98	Huh			
	AC	6,042,996 /	03/28/00	Lin et al.			
gag	AD	6,232,229 B1	05/15/01	Reinberg			
	AE						
	AF						
	AG						
	AH						
	AI						
FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Subclass	Translation Yes No
gag	AJ	59-53842 /	03/28/84	Japan (Seichi et al.)			
	AK	61-177720 /	08/09/86	Japan (Hiroaki et al.)			
	AL						
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)							
gag	AM	Adesida et al., <i>The range of light ions by polymeric resists</i> , J. APPL. PHYS. 56 (6), pp. 1801-1807 /					
		(September 15, 1984).					
gag	AN	Meingailis et al., <i>A review of ion projection lithography</i> , J. Vac. Sci. Technol. B 16(3), pp. 927-956 /					
		(May/June 1998).					
	AO						
EXAMINER		DATE CONSIDERED					
George Goudreau		12-04					
<p>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</p>							